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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 6435**  
Takahisa HAYASHI : Docket No. 2003\_1559A  
Serial No. 10/699,734 : Group Art Unit 2826  
Filed November 4, 2003 : Examiner Victor A. Mandala

SEMICONDUCTOR DEVICE AND METHOD  
OF MANUFACTURING THE SAME

**RESPONSE**

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of June 28, 2004, Applicant in the above-referenced U.S.  
Patent application elects the invention of Group I, corresponding to claims 1-5.

An early and favorable action on the merits is respectfully requested.

Respectfully submitted,

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